



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Patton et al.

Atty Dkt No.: NOVLP016C1/NVLS-000403C1

Application No.: 10/693,223

Examiner: Nguyen, H.

Filed: October 24, 2003

Group: 2812

Title: SEQUENTIAL STATION TOOL FOR
WET PROCESSING OF
SEMICONDUCTOR WAFERS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on March 8, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

Tara Hayden

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated December 13, 2004, please amend the above-identified application as follows:

Amendments to the Claims appear in the Listing of Claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.